Assembly of Molten Transition Metal Salt–Surfactant in a Confined Space for the Synthesis of Mesoporous Metal Oxide–Rich Metal Oxide–Silica Thin Films

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ABSTRACT: Uniform and homogeneous coating of mesoporous materials with an active (catalytically, photonic, electrical) nanostructure can be very useful for a number of applications. Understanding chemical reactions in a confined space is important in order to design new advanced materials. In this work, we demonstrate that an extensive amount (as high as 53 mol percent) of transition metal salts can be confined between silica walls and two surfactant domains (cetyltrimethylammonium bromide, CTAB, and lauryl ether, C12H25(OCH2CH2)10OH, C12EO10) as molten salts and then converted into sponge-like mesoporous silica–metal oxides by thermal annealing. This investigation has been carried out using two different salts, namely, zinc nitrate hexahydrate, [Zn(H2O)6](NO3)2, and cadmium nitrate tetrahydrate, [Cd(H2O)4](NO3)2, in a broad range of salt concentrations. The ZnO (or CdO) layers are as thin as about ∼1.6 nm and are homogenously coated as crystalline nano-islands over the silica pore walls.

KEYWORDS: mesoporous materials, metal oxides, thin films, molten phase, lyotropic liquid crystals, confinement effect

1. INTRODUCTION

The liquid crystalline templating (LCT)1 and evaporation-induced self-assembly (EISA)2 processes have opened a new era for designing new materials in the form of mesostructured mesoporous thin films.1−3 The surface modification of mesoporous materials with metal oxides, sulﬁdes, and selenides is needed to create advanced applications. In the existing literature, metal ions are usually incorporated into the pores by impregnation and then converted to their oxides, sulﬁdes, selenides, and metals.4−15 Salt-water-surfactant lyotropic liquid crystalline (LLC) mesophases have also been adopted to incorporate salt species into the meso-channels of the mesostructured ﬁlms and monoliths.16−18 However, all these methods produced metal oxide nanoparticles with a size of a few nanometers in the mesoporous silica in relatively low amounts. Unfortunately, no methods are available to coat the internal surface of mesoporous materials with materials less than 2.0 nm. Recently, Wang et al.19 have introduced a solid-state grinding method to incorporate salt species into the as-prepared mesostructured silica powder that can be converted into homogeneously coated mesoporous silica–metal oxide upon calcination.19−24 In the as-prepared samples, it is likely that the salt species are conﬁned in the molten phase between the silica walls and surfactant aggregates. Using this approach, the metal oxide to silica ratio has been improved to 35 w/w%. However, above 35 w/w%, this method also fails and produces larger metal oxide particles outside of the pores. Maximum loading only ensures about 15% of the silica walls are being coated with metal oxide with a thickness of less than 2.0 nm. Over all, these methods use multiple steps and pre-prepared mesoporous silica powders and are not applicable to thin ﬁlms.

Recently, we have introduced that two surfactants (a charged surfactant, such as CTAB or SDS, and a nonionic surfactant, such as C12H25+(OCH2CH2)10−OH, represented as C12EO10) and an extensive amount of zinc nitrate hexahydrate (ZnX) can be mixed to form LLC mesophases.25,26 We have also found that the salt species are in the molten phase in the salt–surfactant LLC mesophases.27 Note also that most metal nitrates have very low melting points. For instance, the melting points of ZnX and cadmium nitrate tetrahydrate (CdY) salts are as low as 36.4 and 56 °C, respectively. The melting point of ZnX scales as a function of 1/d (ΔT = 116/d, where ΔT is the melting point change from the bulk ZnX, d is the diameter of the space in nanometers, and 116 is a constant) in a conﬁned space.28 This means that if one puts ZnX in a 3.0 nm pore (typical in mesoporous materials), its melting point decreases to −2.3 °C. Confining salt species in the mesostructure decreases the melting point of the salt and keeps the salt species in the liquid phase. This concept has been used to determine the pore size of nanoporous materials by ﬁlling the pores with molten zinc nitrate salt28 and to design salt–surfactant lyotropic liquid crystalline mesophases.29−32

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In this contribution, the salt—surfactants LLC mesophase has been employed for the first time to encapsulate as high as 60 or 71 w/w% salt species (ZnX or CdX, respectively) between the silica walls and surfactant domains in the channels of mesostructured silica that can be calcined to form uniformly coated mesoporous zinc oxide—silica or cadmium oxide—silica thin films.

2. EXPERIMENTAL SECTION

2.1. Sample Preparation. A mixture of a desired amount of ZnX ([Zn(H2O)6](NO3)2) or CdY ([Cd(H2O)6](NO3)2), 0.291 g CTAB, 0.500 g C12EO10, and 4.500 g deionized water was vigorously stirred for 1 day to get a clear solution. Then 0.050 g of concentrated HNO3 was added to the above solution and stirred for another 5 min. Finally, 0.850 g TMOS was added to the mixture and stirred for an additional 5 min. Note that the solution must be homogeneous and clear before spin coating over any substrate. A few drops of the above solution was put on a substrate over the spin coater and spanned for 1 min at 1200 or 3500 rpm (for the TEM imaging). Immediately after spin coating the films, the ZnX and CdY film samples were put into an oven by 100 min) to obtain the unreacted excess H2S gas from the reaction media for aging at 55 and 65 °C, respectively. The calcined sample was labeled as ZnX-1.14, the amounts of ZnX, CTAB, C12EO10, H2O, HNO3, and TMOS are 1.900, 0.291, 0.500, 4.500, 0.050, and 0.850 g, respectively. The calcined sample was labeled as ZnO-1.14.

2.2. Synthesis of meso-SiO2–CdS Thin Films. Insert the calcined meso-SiO2–CdO-n thin films into a vacuum chamber and evacuate the chamber for 2 min. Expose the meso-SiO2–CdO-n samples to 300 Torr H2S(g) until complete reaction (about 100 min) to obtain meso-SiO2–CdS-n thin films. Then, pump out the unreacted excess H2S gas from the reaction media for 5 min before removing the sample from the reaction chamber.

2.2. Characterization. The FTIR spectra were recorded using a Bruker Tensor 27 model FTIR spectrometer. A Digi Tect TM DLATGS detector was used with a resolution of 4.0 cm−1 in the 400–4000 cm−1 range. The spectra were recorded using the samples coated on silicon wafers or using dry KBr pellets. The UV−vis absorption spectra were recorded using thin films coated over quartz substrates and a Thermofall Scientific Evolution 300/600 UV—visible spectrometer. The XRD patterns were recorded on a Rigaku Miniflex and Pananalytical multipurpose X-ray diffractometer using a high power Cu Kα source operating at 30 kV/15 mA and 45 kV/40 mA, respectively. The POM images were obtained in transmittance mode on a ZEISS Axio Scope A1 polarizing optical microscope. The SEM images were recorded using a Hitachi HD-2000 STEM in SEM mode, and the EDS data was collected using a ZEISS EVO-40 SEM operated at 15 kV with a Bruker AXS XFlash detector 4010 attached to the same microscope. The high resolution transmittance electron microscope (HRTEM) images were recorded on a FEI Technai G2 F30 at an operating voltage of 200 kV. The calcined film samples were scribed and ground in a mortar with 5 mL of acetone and dispersed using sonication for 5 min. One drop of the dispersed acetone solution was put on a TEM grid and dried over a hot plate. The N2 (77.4 K) sorption measurements were performed with a TriStar 3000 automated gas adsorption analyzer (Micrometrics) in a relative pressure range, P/P0, from 0.01 to 0.99. To provide high accuracy and precision in the determination of P/P0, the saturation pressure P0 was measured over 120 min intervals. The powder samples, which were obtained by scraping about 20 glass slides of each film sample were dehydrated under (~10−2 Torr) vacuum for 3 h at 300 °C before measuring in order to remove adsorbed water and volatile species in the pores.

3. RESULTS AND DISCUSSION

The film samples were prepared by spin coating a clear solution of CTAB, C12EO10, ZnX (or CdY), HNO3, water, and TMOS. The content of the solutions has been optimized by changing the salt and CTAB concentrations. We found that the salt and CTAB concentrations, for stable samples, depend on each other (to incorporate a large amount of salt, one needs a high CTAB concentration). The film samples were prepared at ZnX/C12EO10 mole ratios of 2.0, 4.0, 6.0, 8.0, 10.0, and 12.0, corresponding to a ZnX/SiO2 mole ratio of n, where n is 0.29, 0.57, 0.86, 1.14, 1.43, and 1.71, respectively, and represented as meso-SiO2–ZnX-n. Notice that the minimum salt concentrations investigated in this work are the maximum concentrations in the current literature.19−24 The fresh film sample undergoes crystallization unless it is kept above 55 and 65 °C for meso-SiO2–ZnX-n and meso-SiO2–CdY-n, respectively. The initial temperatures were determined on the basis of the stability of the LLC phase of the mixture and the melting point of the salts. This step is followed by calcination using a temperature controlled oven from the pre-aged temperature to 450 °C with a 1 °C/min intervals.
A slow calcination of the meso-SiO$_2$–ZnX–n and meso-SiO$_2$–CdY–n, starting at 55 and 65 °C (1 °C/min up to 450 °C), respectively, immediately after spin coating produces transparent mesoporous films, represented as meso-SiO$_2$–ZnO–n and meso-SiO$_2$–CdO–n, respectively. Above a 10.0 salt/C$_{12}$EO$_{10}$ mole ratio (corresponds to salt/silica mole ratio of 1.43), the film samples leach out some of the salt species and form bulk oxide. Fortunately, below an 8 salt/C$_{12}$EO$_{10}$ mole ratio (about a salt/silica mole ratio of 1.14), no bulk oxides have been observed over the thin film samples. Note also that the small angle diffraction line due to the mesostructure becomes very broad around 100–150 °C and lost around 250 °C during the calcination step, indicating a completely disordered mesoporosity that has been proven using N$_2$ sorption measurements and TEM imaging (see later). For further insight on the structure of the nano-islands in the calcined films, we also recorded the wide angle XRD pattern of the samples that display broad features due to amorphous silica and extremely small oxide domains (Figure S1 of the Supporting Information).

The FTIR spectra of the meso-SiO$_2$–ZnX–n and meso-SiO$_2$–CdY–n (where n is 0.29, 0.57, 0.86, 1.14, and 1.43) samples display peaks between 1250 and 1500 cm$^{-1}$ due to nitrate ion coordinated to Zn(II) or Cd(II) ion in the media; these peaks monotonically increase with increasing salt amounts in the samples (Figure S2 of the Supporting Information). At low salt concentrations, these peaks are better resolved, but at higher concentrations the spectra become similar to that of pure molten salt (Figure S2a,b of the Supporting Information).$^{27}$ In this assembly process, the salt species are confined between the silica walls and ethylene oxide domains of the surfactants in the channel spaces of the mesostructured silica, likely in the molten phase. Otherwise, it is impossible to dissolve such a high concentration of salt in a solid matrix, such as mesostructured silica without crystallization of the salt species. Heating the meso-SiO$_2$–ZnX–n sample to 65 °C enhances intensity of the peaks.
at 1290 and 1460 cm\(^{-1}\) (Figure S2c of the Supporting Information). Clearly, the nitrate ions are coordinating to the metal ion by the evaporation of water molecules and stabilizing the ionic species by reducing the charge density of the media in the film samples. Note also that the nitrate peaks start to gradually lose their intensities upon further heating the film samples around 100 °C and completely disappear around 200 °C (Figure S2 of the Supporting Information). Further heating of the samples results in mesoporous thin films, represented as meso-SiO\(_2\)-MO-\(n\) (where M is Zn or Cd and \(n\) is the MO/silica mole ratio). Panels (a) and (b) of Figure 2 show a series of FTIR spectra recorded from the meso-SiO\(_2\)-ZnO-\(n\) and meso-SiO\(_2\)-CdO-\(n\) samples, respectively, upon calcination at 450 °C. The peaks around 926 cm\(^{-1}\) in the meso-SiO\(_2\)-ZnO-\(n\) samples and at 914 and 864 cm\(^{-1}\) in the meso-SiO\(_2\)-CdO-\(n\) samples correspond to the \(\nu\)-SiO stretching mode\(^{33,34}\) of the silica–metal oxide interface, Si–O–Zn and Si–O–Cd, respectively. Further analysis of the FTIR spectra showed that the coating of the silica walls with zinc oxide starts as low as 100 °C from the Si–OH side of the framework. The intensity of the peaks at 538 and 926 cm\(^{-1}\) in the spectra of meso-SiO\(_2\)-ZnO-\(n\) gradually increase with increasing zinc oxide component of the samples up to a 1.14 metal oxide/silica mole ratio (Figure 2a). Above a 1.14 mol ratio, the pure silica peak at 456 cm\(^{-1}\) becomes visible in the spectra of meso-SiO\(_2\)-ZnO-1.43 (see top spectrum in Figure 2a) and meso-SiO\(_2\)-ZnO-1.71 (not shown) due to leaching and growth of the ZnO species in the samples. Similar changes occur in the meso-SiO\(_2\)-CdO-\(n\) samples; the peaks at 505 and 914 cm\(^{-1}\) (due to CdO and Si–O–Cd stretching) gradually increase with increasing CdO concentration up to 0.86
Cd(II) of the silicon mole ratio. Above 0.86 mol ratio, another peak at 864 cm\(^{-1}\) appears and increase in intensity occurs with further increasing the metal ion content of the sample (Figure 2b).

Notice that even though there is also leaching of the excess CdY species in the \(\text{meso-SiO}_2-\text{CdY}-n\) thin films, above a 1.14 mol ratio, the pure silica formation was not observed in the \(\text{meso-SiO}_2-\text{CdO}-n\) samples. This means that the silica-cadmium oxide interface is much stronger, and the cadmium ions are more reactive with the silica, in that there is no cleavage of the Si-O-Cd bonds. This observation is reasonable because the silica is an acid and CdO is a stronger base than ZnO. The stronger interaction of CdO ensures better surface coverage compared to ZnO, see latter. The FTIR spectrum of \(\text{meso-SiO}_2-\text{CdO}-1.14\) also displays peaks at around 1300–1600 cm\(^{-1}\) region due to unburned organic impurities. The \(\text{meso-SiO}_2-\text{ZnO}-1.14\) sample was further heated at 550, 650, and 750 °C to remove the unburned organic impurities and to check the stability of the samples at a higher temperature using FTIR spectroscopy (Figure S2d of the Supporting Information). The impurity peaks completely disappears at around 550 °C. However, the heating at 750 °C causes separation of the silica and ZnO; evolution of the peaks at 1100 and 456 cm\(^{-1}\) due to pure silica approves the separation of silica and ZnO species (Figure S2d of the Supporting Information).

The film samples were further analyzed using N\(_2\) adsorption–desorption measurements using samples obtained from tens of glass slides, which were coated, calcined, and collected by scraping. Note also that it is extremely difficult to collect samples for the N\(_2\) sorption measurements from the \(\text{meso-SiO}_2-\text{ZnO}-0.29\) and \(\text{meso-SiO}_2-\text{CdO}-0.29\) samples. Therefore the N\(_2\) sorption measurements were limited to the \(\text{meso-SiO}_2-\text{MO}-n\) samples (where M is Zn(II) and Cd(II), and \(n\) is 0.57, 0.86, and 1.14). All the N\(_2\) sorption data display type IV isotherms, characteristic of the mesoporous materials (Figure 3a,b). The BET surface areas are 430, 175, and 130 m\(^2\)/g in the \(\text{meso-SiO}_2-\text{ZnO}-n\) samples and 85, 55, and 50 m\(^2\)/g in the \(\text{meso-SiO}_2-\text{CdO}-n\) samples, where \(n\) is 0.57, 0.86, and 1.14, respectively. The surface area of the metal oxide free mesoporous silica is 950 m\(^2\)/g with a relatively narrow pore size distribution centered at 2.1 nm (Figure 3c,d). However, the BJH pore size distribution curves of the metal oxide-containing samples become broader with increasing metal oxide content in the samples (Figure 3c,d). It increases from 3.4 to 12.4 nm in the \(\text{meso-SiO}_2-\text{ZnO}-n\) and 5.4 to 13.5 nm in the \(\text{meso-SiO}_2-\text{CdO}-n\) samples.

![Figure 5. TEM images of the meso-SiO\(_2\)-CdO-n; \(n\) is (a,b) 0.57, (c) 0.86, and (d) 1.14. (e) HRTEM image of the meso-SiO\(_2\)-CdO-0.86 sample and the FT (f) and inverse FFT (g) of the marked region of panel (e).](image)

![Figure 6. Direct gap fitting of UV–vis absorption spectra of (a) meso-SiO\(_2\)-ZnO-n \([n\) is the ZnO/SiO\(_2\) mole ratio; inset is a table of composition (ZnO/SiO\(_2\) mole ratio) and band gap values (eV)] and (b) meso-SiO\(_2\)-CdO-n \([n\) is the CdO/SiO\(_2\) mole ratio; inset is a table of composition (CdO/SiO\(_2\) mole ratio) and band gap values (eV)].](image)
Table 1. Parameter for Surface Loading Calculated from Measured Data

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<th>System</th>
<th>Surface Area of meso-SiO₂</th>
<th>Surface Area for 1 g of Metal Oxide</th>
<th>% Loading Based on TEM</th>
<th>% Loading Based on UV–vis Data</th>
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<tr>
<td>meso-SiO₂–CdO–n (CdO/SiO₂ mole ratio)</td>
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<td>m²/g</td>
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<tr>
<td>0.57</td>
<td>85</td>
<td>154</td>
<td>50</td>
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<table>
<thead>
<tr>
<th>System</th>
<th>Surface Area of meso-SiO₂–ZnO–n</th>
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<th>% Loading Based on TEM</th>
<th>% Loading Based on UV–vis Data</th>
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<td>1.14</td>
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<td>12</td>
<td>13</td>
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</table>

The samples that show more than 100% loading may contain some bulk CdO or it can be accepted within the accuracy range of BET measurement (10% is typical for the BET measurements). BET data. c Calculated on the basis of BET data (for each gram of the metal oxide). d Surface area of a flat 1 g and 1.6 nm thick metal oxide film (thickness was calculated from the UV–vis data) over a substrate divide by the surface area measured (BET).

Figure 7. meso-SiO₂–CdO-0.86 film upon HF etching. (a) TEM image (b) FFT of a large area, (c) SAED pattern, and (d) magnified TEM image.

samples. The samples at high metal oxide concentrations display two pore systems, one with a relatively narrower and smaller pore size and another that is larger and broader. Clearly, the pore system changes in the presence of a large amount of metal oxide in the meso-SiO₂-MO-n films. The pore walls are likely thicker than the pore walls in the pure silica (Scheme 1). The schema also summarizes the assembly and formation of the mesoporous silica–metal oxide thin films. Furthermore, a triangular H2-type hysteresis loop in the meso-SiO₂–ZnO-0.57 sample and a two-step desorption process for the meso-SiO₂–CdO-0.86 sample indicate pronounced pore blocking in the first case (ink-bottle type pores with small apertures, or plugs in the channels) and distribution of pore overture sizes in the second (possibly due to nonuniform distribution of the guests in the pores of the materials). These observations are consistent with increasing loading of metal oxides with a nonuniform distribution of the metal oxide species in the pores.

For further insight on the structural details of the films, a series of TEM and SEM images together with EDS data have also been collected and analyzed from a group of samples. Panels (a) and (b) of Figure 4 are the SEM images of the meso-SiO₂–ZnO-1.14 sample. The images show sponge-like disordered mesosstructures. The EDS data collected from various parts of the films using Si, O, and Zn (or Cd) lines shows similar elemental composition, indicating homogeneous distribution of the silica and metal oxide domains in the films. Panels (c–e) of Figure 4 display TEM images of the meso-SiO₂–ZnO-0.86, meso-SiO₂–ZnO-1.14, and meso-SiO₂–ZnO-0.57 samples, respectively. The TEM images show sponge-like disordered features in all samples. The thickness of the features is on average 1.4–1.6 nm (Figure 4e). The TEM images show that the darker domains are nanocrystalline; the lattice fringes can be clearly observed. The contrast analysis along the yellow line, shown in the inset of Figure 4e, clearly shows that the lattice fringes are 0.281 nm apart, originating from the (100) planes of wurtzite ZnO nanocrystallites. Furthermore, the fast Fourier transform (FFT) of a selected area of the image gives lattice spots located at 3.55, 3.85, and 6.15 nm⁻¹, corresponding to lattice spacing of 0.281, 0.260, and 0.162 nm, originating from the (100), (002), and (110) lattice planes of the ZnO nanocrystallites (Figure 4f). Note also that the calculated unit cell parameters (about a = 0.325 and c = 0.520 nm) are consistent with the unit cell parameters of wurtzite ZnO. Figure 5 shows a series of TEM images obtained from the meso-SiO₂–CdO-n samples, where n is 0.57, 0.86, and 1.14. Panel (a) of Figure 5 shows sponge-like mesoporous small domains. Panels (b–d) of Figure 5 show that the pore walls are nanocrystalline CdO in all compositions.
Clearly, the darker contrast in the images guides the disordered mesopores as discussed in the N2 sorption section. The FFT and its inverse FFT of the selected region in the TEM image display lattice spots and fringes in the darker regions of the images. Careful analysis of the TEM images identifies lattice fringes, spaced by 0.332, 0.271, and 0.235 nm, originating from the NaCl structure of nanocrystalline CdO. These lattice fringes correspond to (110), (111), and (200) planes, respectively, of the cubic CdO lattice with a unit cell constant of 0.469 nm.36

The UV–vis absorption spectra of both meso-SiO2–ZnO–n and meso-SiO2–CdO–n samples were also recorded using the film samples coated over quartz slides (Figure S3a of the Supporting Information and Figure 6). Notice that the absorption intensity and absorption edge in the UV region gradually increase and red shift with the increasing ZnO content of the samples (Figures S3a of the Supporting Information and Figure 6a). A similar trend is observed from the meso-SiO2–CdO–n samples (Figure 6b). The blue shift from the bulk band gap (3.37 eV) is 2.48 and 1.52 eV for the meso-SiO2–ZnO–0.29 and meso-SiO2–ZnO–1.14, respectively; all other compositions are between these two band gap values, which follow an exponential decay (Figure S3b of the Supporting Information). The large blue shift is an indication of the existence of extremely small nanoparticles or a few layers of zinc oxide over the silica framework. The blue shift is due to the quantum confinement effect and corresponds to a thickness or particle size of around 1.4 to 1.7 nm, calculated using effective-mass model (Figure S3b of the Supporting Information). The absorption edge of the meso-SiO2–CdO–n film samples also follows a similar trend, where the shift from the bulk CdO is even larger (Figure 6b). The shift from the bulk CdO is 2.84 eV in the meso-SiO2–CdO–1.14 corresponds to a film thickness of 1.6 nm (Figure S3b of the Supporting Information for the other compositions). The thickness or the particle size calculated from the absorption edge is consistent with the particle size/thickness determined from the TEM images.

Combining the results of FTIR and UV–vis absorption spectroscopy, N2 sorption data, and TEM images shows that the silanol groups of the silica framework react with the metal ions to form Si–O–M bonds at the silica–metal oxide interface on the pore walls, where the metal oxides are grown from those sides. The surface coverage, listed in Table 1, was calculated using the BET, UV–vis, and TEM data (details are given in the table footnotes). Complete coverage of the silica surface was achieved at around 0.86 Cd(II) per silicon in the meso-SiO2–CdO–n sample, but even at 1.14 Zn(II) per silicon, the surface coverage in the meso-SiO2–ZnO–n sample is about 50% (Table 1). Notice that the Si–O–M stretching mode around the 850–1000 cm⁻¹ region gradually increases with increasing metal ion concentration of the samples up to a 1.14 Zn(II) to silicon ratio (Figure 2a and Figure S4 of the Supporting Information), clearly showing the surface coverage continues up to a 1.14 Zn(II) to silica mole ratio. Furthermore, the particle size that was determined using the TEM images and UV–vis absorption edge (from the band gap using effective mass model) is very similar in all compositions. The absorption edge gradually increases but not at the same rate as the metal to silicon mole ratio. The spectral changes (gradual increase in the Si–O–M stretching mode and shallow increase in the absorption edge) and similar particle size in the TEM images, with an increasing metal oxide concentration in the meso-SiO2–MO–n thin films eliminate the possibility of first full monolayer coverage on the silica wall surface and then growth of the nanocrystalline metal oxides over the silica walls.27 It is likely that the metal oxides on the pore surface of the mesoporous silica form thin metal oxide nano-islands. These islands grow and cover the surface of the mesoporous silica in the CdO case.

To further prove our hypothesis, the silica walls of the meso-SiO2–CdO–0.86 film were gently etched using a 4% aqueous HF solution. Figure 7 shows TEM images, an FFT of a large TEM image, and a SAED pattern. The TEM images show plate-like features with lattice fringes corresponding to crystalline CdO.

Figure 8. FTIR spectra of (a) (I) pure meso-SiO2 and before (II) and after H2Se reaction of meso-SiO2–CdO–0.86, (b) before (I) and after (II) H2S reaction of meso-SiO2–CdO–0.86. The Raman spectra of (c) meso-SiO2–CdS–0.86 and (d) meso-SiO2–CdSe–0.86 thin films.
nano-islands (Figure 7a,d). Notice that these particles are as large as $10-15$ nm with a likely thickness of around 1.6 nm as determined from their UV–vis absorption spectra. Note also that the absorption edge does not change upon etching. The FFT of a large area TEM image shows two rings, originating from the (200) and (220) planes of crystalline CdO. The SAED pattern also displays diffraction rings from the (200) and (220) planes and weaker rings from higher-order planes corresponding to a face-centered cubic CdO (Figure 7c). These observations clearly ensure that the metal oxides are growing over the silica walls and eliminate the possibility of mixed oxide formation during the annealing stage of the preparation.

The presence of CdO nano-islands in the $\text{meso-SiO}_2-\text{CdO-n}$ films were further confirmed by reacting the samples under $\text{H}_2\text{S}$ or $\text{H}_2\text{Se}$ atmospheres at room temperature to convert CdO nano-islands into CdS or CdSe nano-islands, respectively. The $\text{H}_2\text{S}$ reaction proceeds until all Si–O–Cd bonds break, as monitored using FTIR spectroscopy (Figure 8a,b). The $\text{meso-SiO}_2-\text{CdO-n}$ samples display a peak and a shoulder at 914 and 864 cm$^{-1}$, respectively, due to the O$_3$Si–O–Cd(O)$_6$ interface species; the CdO are nanocrystalline on the silica surface with cubic (6 coordinated) structures. The peaks due to the Si–O–M bonds disappear and the peaks, due to the pure silica, appear upon completion of the $\text{H}_2\text{Se}$ or $\text{H}_2\text{S}$ reactions (Figure 8a,b). The spectra of all the samples after complete $\text{H}_2\text{S}$ and $\text{H}_2\text{Se}$
reactions closely resemble the spectrum of the pure silica. The Raman spectra of the meso-SiO$_2$–CdS–n and meso-SiO$_2$–CdSe–n films show resonance Raman effects and display intense peaks due to longitudinal optical (LO) modes at 298 and 205 cm$^{-1}$, respectively, with shoulders on their low energy side due to surface modes$^{39}$ (Figure 8c,d). The EDS data show a linear increase in the Zn/Si and Cd/Si intensity ratios with an increasing n in the samples (meso-SiO$_2$–CdS–n (or CdSe–n)), where n is 0.29, 0.57, 0.86, and 1.14, indicating the homogeneity in the samples. The complete conversion of the cadmium oxide to cadmium sulfide or to cadmium selenide was also ensured using the EDS data; note that the S/Cd and Se/Cd intensity ratios are the same as their bulk counter parts upon completion of the corresponding reactions.

To further investigate the structural details of the films upon H$_2$S or H$_2$Se reactions, we also recorded the TEM images of a series of samples (Figure 9). Panel (a) of Figure 9 is a TEM image obtained from the meso-SiO$_2$–CdS–0.86 film. The image shows lattice fringes from the crystalline CdS domains. A histogram of the line (I) is shown in the right corner of the image in panel (a) of Figure 9, where the distance between the lattice fringes is 0.335 nm and corresponds to the (111) planes of the zinc blende CdS nanocrystallites.$^{40}$ Notice also that there are 15 nm (line II) and 3.0 nm (line III and yellow partial circle) crystalline domains (Figure 9c). The crystalline domains likely originate from the nano-islands along the lines (I) and (II) are spaced by 0.335 nm, corresponding to the (111) planes of the CdS lattice (Figure 9c). The lattice fringes along the lines (I) and (II) are spaced by 0.335 nm, corresponding to the (111) planes of the CdS lattice (Figure 9c). The SAED patterns are also identical before and after the HF treatment, indicating that the CdS particles are as dispersed and random as before the HF treatment (Figure 9d). Each ring from inside to out corresponds to the (111), (220), and (311) planes of the zinc blende CdS. The details of the H$_2$S and H$_2$Se reactions and further characterization of these samples will be presented elsewhere.

4. CONCLUSION

The salt–surfactant LLC mesophase concept and the EISA method have been successfully employed to encapsulate up to a 1.14 salt (ZnX or CdY) per silica mole ratio in the mesostructured silica films. We took advantage of the salt–surfactant system, in which the primary solvent is the salt in its molten phase. Notice that this solvent does not evaporate during the assembly and calcination process to design mesoporous silica–metal oxide thin films. This property of the salt–surfactant LLC mesophase system clearly distinguishes from the EISA process. We found that two parameters are critically important in this assembly process: one is the amount of charge surfactant (CTAB) that compensates the surface charges of the molten salt domains, confined between the silica walls and surfactant domains in the mesostructured thin films, and the other is the effect of confined space that depresses the freezing point of the salt used. The calcined film samples contain uniformly coated 1.4–1.7 nm thick crystalline metal oxide nano-islands on the pore walls of mesoporous silica films. Using this approach, the metal oxide on the pore walls can be adjusted up to 61 and 71 w/o% in the meso-SiO$_2$–ZnO–n and meso-SiO$_2$–CdO–n samples, respectively. An $\sim$100% and $\sim$50% surface coverage can be achieved in the meso-SiO$_2$–CdO–n and meso-SiO$_2$–ZnO–n thin films using the method developed in this work. The nanocrystallites form as nano-islands and spatially grow to cover the silica surface. Finally, the metal oxide nano-islands can be recovered by etching out the silica layers. The method is not limited to ZnO and CdO; it can be employed for other salts and metal oxides, mixed metal oxides, metal sulfides, and metal selenides, etc.

ASSOCIATED CONTENT

Supporting Information. Wide-angle XRD patterns, FTIR spectra of all the fresh coated films, temperature-dependent FTIR spectra, UV–vis absorption spectra of meso-SiO$_2$–ZnO–n films, plot of thickness of the oxide nano-islands versus composition, and convoluted FTIR spectra of the Si–O–M stretching region of meso-SiO$_2$–ZnO–n films (PDF). This material is available free of charge via the Internet at http://pubs.acs.org.

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